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PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Serial No.: 10/085,128

Confirmation No.: 2733

In re Application of:

Kiyoshi ARITA et al.

Group Art Unit: 1765

Filed: March 1, 2002

Examiner: Duy Vu Nguyen Deo

For: PLASMA PROCESSING METHOD

AMENDMENT

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, Virginia 22313-1450

Sir:

In response to the Office Action mailed April 16, 2004,  
please amend the above-identified application as follows:

PLEASE ACCEPT THIS AS  
AUTHORIZATION TO DEBIT  
OR CREDIT FEES TO  
DEP. ACCT. 16-0331  
PARKHURST & WENDEL